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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/532,991 Confirmation No. : 2959
First Named Inventor : Mitsuhiro YUASA
Filed : April 28, 2005
TC/A.U. : 2812
Examiner : Mohsen AHMADI

Docket No. : 101249.56268US
Customer No. : 23911

Title : Process Monitor and System for Producing Semiconductor

REPLY

Mail Stop AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following amendments and remarks are respectfully submitted in response to the non-final Office Action dated February 24, 2006.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.